

## Supplement Information

### Solvent Annealing of $\text{PbI}_2$ for High-Quality Crystallization of Perovskite Films for Solar Cells with Efficiency Exceeding 18%

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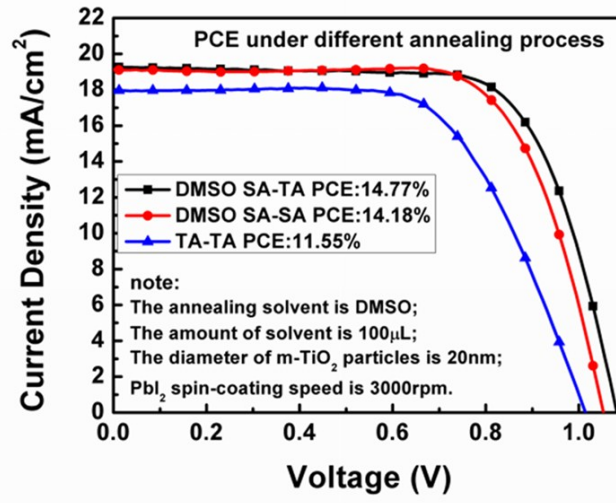
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In this investigation, using the DMSO SA-TA process, a series of experiment parameters were studied to optimize the performance of solar cells. At first, we studied the TA-TA, DMSO SA-TA, DMSO SA-SA as shown in Figure S1, because the TA-SA process did not result in good results as described in the text. We found that the DMSO SA-TA annealing process is the best among TA-TA and DMSO SA-SA processes. This result is consistent with our previous conclusion using DMF in the text. It should be noted that we used the same petri dish. We studied the effect of different DMSO volumes on the device performance as shown in Figure S2. We found negligible difference in PCE by using different volumes of DMSO solution. We chose the volume of 50  $\mu\text{l}$  in our subsequent experiments. The diameter of m-TiO<sub>2</sub>

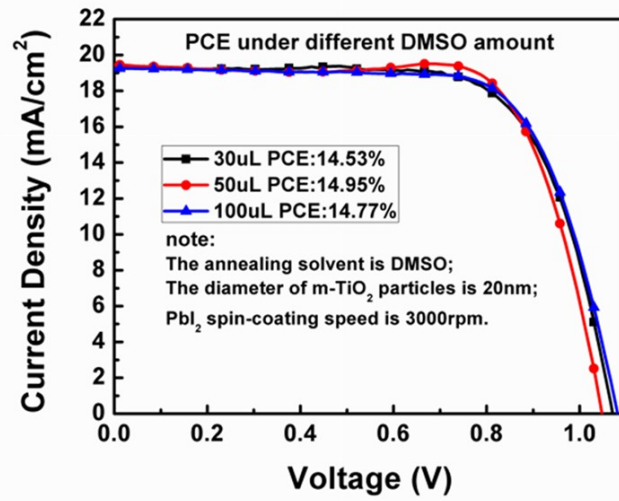
and the spin speed of  $\text{PbI}_2$  were also investigated (Figure S3 and Figure S4). It can be seen in Figure S3 that m-TiO<sub>2</sub> with the diameter of 30 nm results in better PCE. The first spin speed of  $\text{PbI}_2$  significantly affected the device performance. As shown in Figure S4, the first spin speeds of 2500 rpm, 3000 rpm, and 3500 rpm resulted in PCEs of 14%, 15.7%, AND 17.1% separately. In addition, we studied thermal annealing (TA) of  $\text{PbI}_2$  and the DMSO annealing of  $\text{PbI}_2$  at 100°C for 10 min. After thermal annealing at 100°C,  $\text{PbI}_2$  exhibits smooth and dense surface, while after annealing  $\text{PbI}_2$  in DMSO at 100°C we obtained a surface that looks like needles but are actual many  $\text{PbI}_2$  nanowires as shown in Figure S5. This suggests that lower temperature DMSO annealing is better for porous  $\text{PbI}_2$ .

Figure.S1 J-V curves and device performance of devices fabricated using different annealing processes (TA-TA, DMSO SA-TA and DMSO SA-SA ).



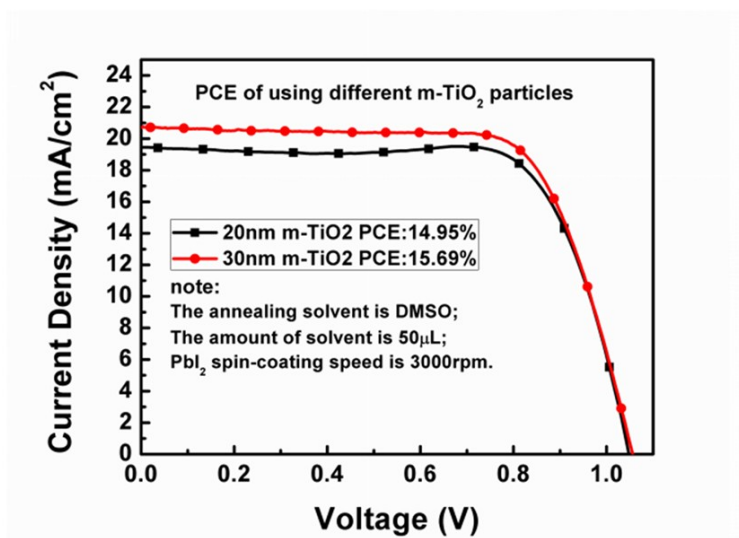
Annealing method	$V_{oc}$ (V)	$J_{sc}$ (mA/cm <sup>2</sup> )	FF (%)	PCE (%)
DMSO SA-TA	1.08	19.27	70.9	14.8
DMSO SA-SA	1.05	19.11	70.5	14.2
TA-TA	1.01	17.94	63.5	11.6

Figure.S2 J-V curves and device performance of solar cells fabricated using different volumes of DMSO solvent in the DMSO SA-TA process.



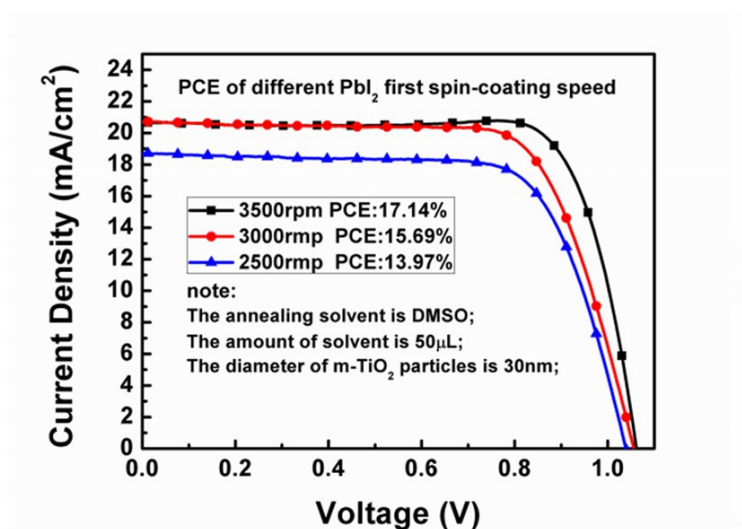
Amount of DMSO in SA process (uL)	$V_{oc}$ (V)	$J_{sc}$ (mA/cm <sup>2</sup> )	FF (%)	PCE (%)
30	1.07	19.28	70.4	14.5
50	1.05	19.46	73.4	14.9
100	1.03	20.10	67.5	14.0

Figure.S3 J-V curves and device performance of devices fabricated using m-TiO<sub>2</sub> with different diameters.



Diameter of m-TiO <sub>2</sub> particles (nm)	V <sub>oc</sub> (V)	J <sub>sc</sub> (mA/cm <sup>2</sup> )	FF (%)	PCE (%)
20	1.05	19.46	73.4	14.9
30	1.05	20.72	71.7	15.7

Figure.S4 J-V curves and device performance of devices fabricated using different spin-coating speeds for  $\text{PbI}_2$ .



Different spin-coating speed of $\text{PbI}_2$ (rpm)	$V_{oc}$ (V)	$J_{sc}$ ( $\text{mA}/\text{cm}^2$ )	FF (%)	PCE (%)
2500	1.04	18.70	71.9	13.9
3000	1.05	20.72	71.7	15.7
3500	1.06	20.68	78.1	17.1

Figure.S5 SEM images of Surface morphology of  $\text{PbI}_2$  films obtained using different annealing processes at 100 °C.

